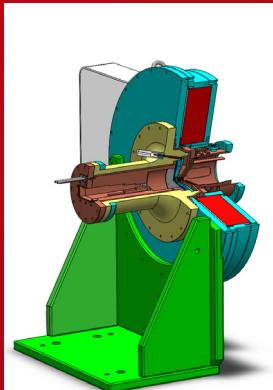


FROM RESEARCH TO INDUSTRY



Olivier DELFERRIERE
Irfu/SACM



www.cea.fr



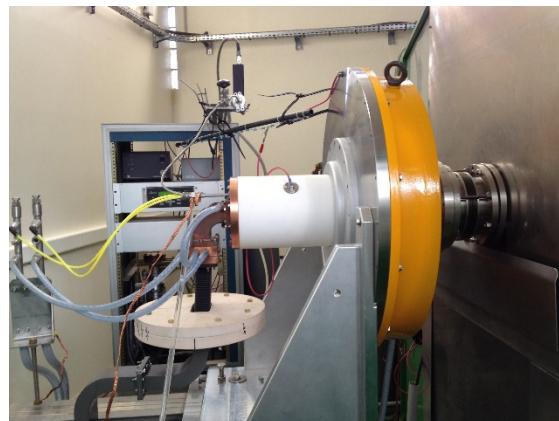
The 22nd International
Workshop on ECR Ion Sources
Busan, Korea

28 August ~ 1 September 2016 < | >

DEVELOPMENT OF A COMPACT HIGH INTENSITY ION SOURCE FOR LIGHT IONS AT CEA-SACLAY

O. Delferrière, R. Gobin, F. Harrault, Y. Gauthier, O. Tuske,

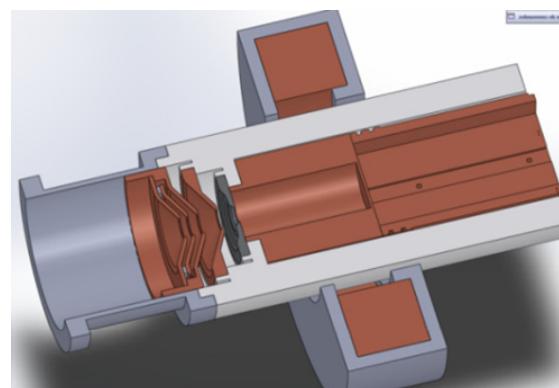
Commissariat à l'Energie Atomique, CEA/Saclay, DRF/Irfu, 91191-Gif/Yvette, France



Main goal of this work : to minimize the divergence and emittance growth of intense beams extracted from ECR ion sources due to space charge effects

Outline:

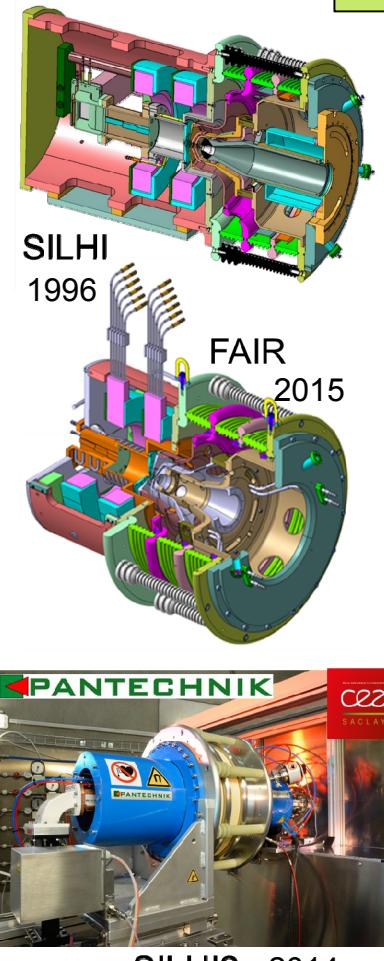
- ❖ High intensity ECR Ion sources developed at Saclay
- ❖ The ALISES concept (*Patent FR 2969371 - 2010*)
- ❖ Development of ALISES source (2009-2012)
- ❖ The Penning discharge problem
- ❖ The compact ECR ion source ALISES II (2014-2015 *Patent FR 1556871 - 2015*)
- ❖ Evolution towards ALISES III (end of 2016)



First idea of concept in 2009

ECR ION SOURCES DEVELOPED AT SACLAY SIMULATIONS, CONCEPTION, FABRICATION

2.45GHz ECR ion sources for projects, but also sources for R&D



Project /Source	High Voltage	Current	Magnetic Configuration
SILHI	100kV	100mA	Coils
IPHI		H ⁺	
IFMIF	100kV	140mA	Coils
EVEDA		D ⁺	
SPIRAL2	20kV 40kV	5mA H ⁺ 5mA D ⁺	Permanent Magnets
FAIR p linac	100kV	100mA H ⁺	
ALISES	23kV	18mA	Coil
ALISES II	50kV	40mA	Coil
SILAP-1	40kV	30mA / 60mA	Permanent Magnets
SILHI2	50kV	40mA H ⁺ ,D ⁺	

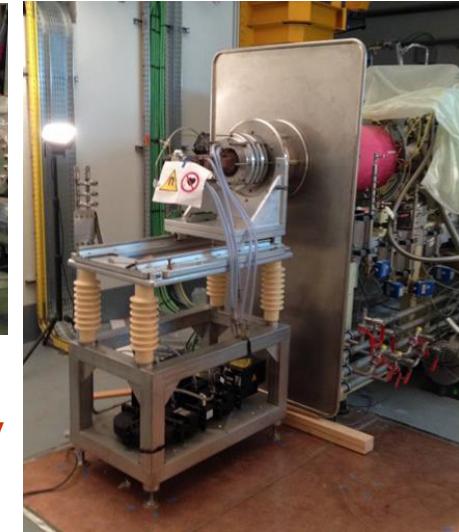
HIGH INTENSITY 2.45 GHz ECR ION SOURCES FOR LIGHT IONS AT SACLAY

OVERVIEW

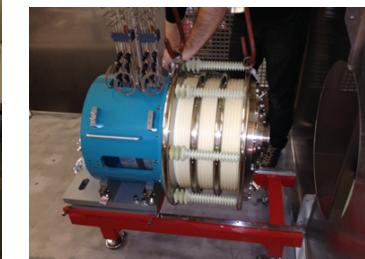
SILHI source
 H^+ 100mA ,95kV CW



IFMIF source
 D^+ 140mA ,100kV CW



SPIRAL2 source
 H^+,D^+ 5mA ,20kV/40kV



FAIR source
 H^+ 100mA ,95kV
4Hz, 4% duty cycle

All these sources have the same basic structure

2 successive ensembles connected :

- [1] A source body = Magnets + plasma chamber + wave guide
- [2] An insulating structure between HV and ground in which an extraction system is connected between plasma chamber and LEBT

High intensity beams means Space charged effects
in LEBT and emittance growth

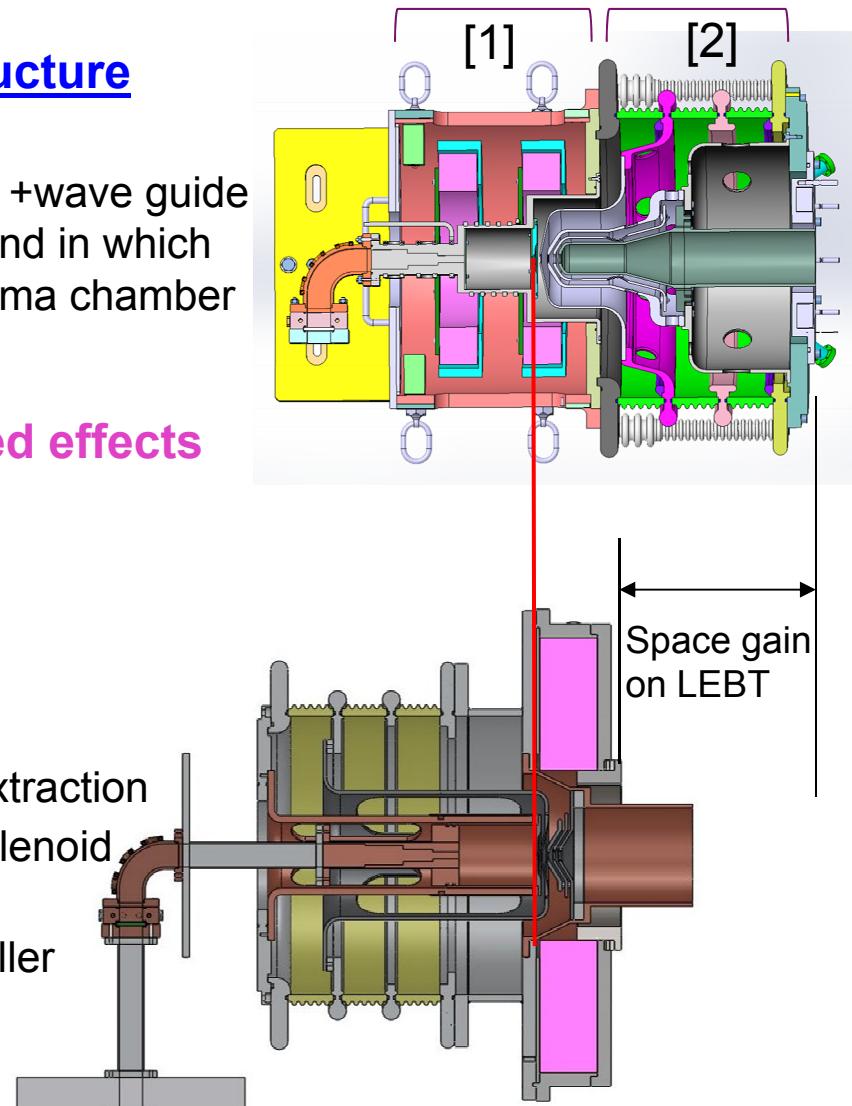
Main objective: Reduction of LEBT length

The ALISES concept

Structure reversed:

- ▶ Put the insulation structure behind the plasma extraction
- ▶ ECR resonance obtained with fringe field of a solenoid on ground potential at the beginning of LEBT
- ▶ Extraction system is simplified, except for the puller

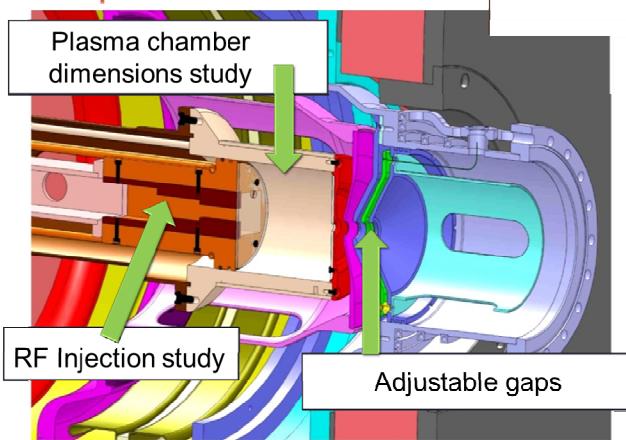
ALISES V1 source



ECR ION SOURCES DEVELOPMENT AT SACLAY THE ALISES CONCEPT

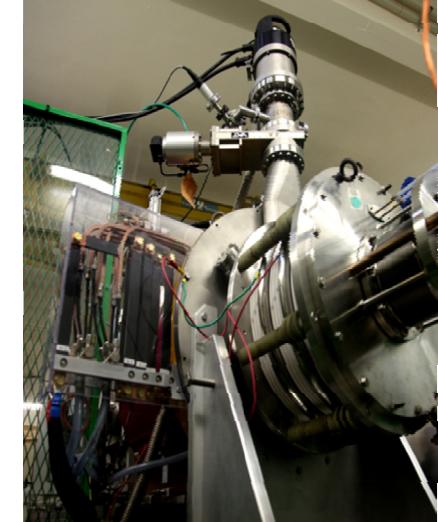
Patent CEA FR1060578

ALISES longitudinal cut

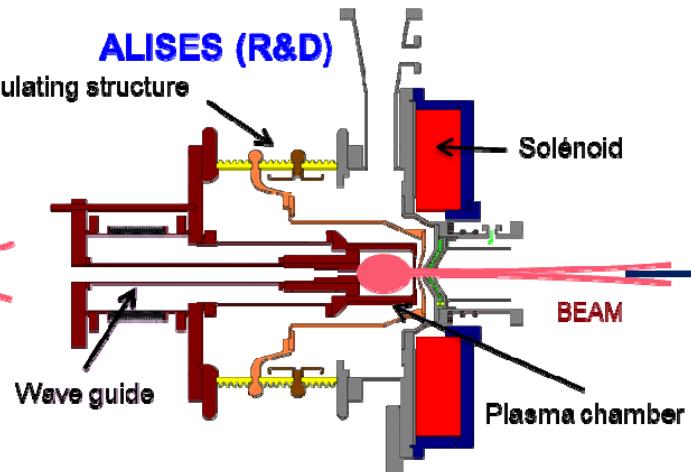
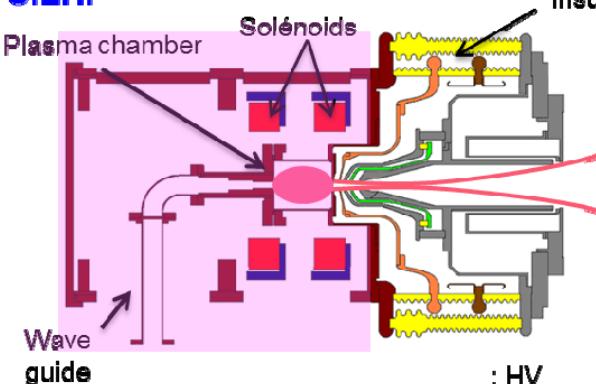


The **ALISES** source has been an innovative development of a new source geometry to simplify the source design and to reduce the length of low energy transfer lines.

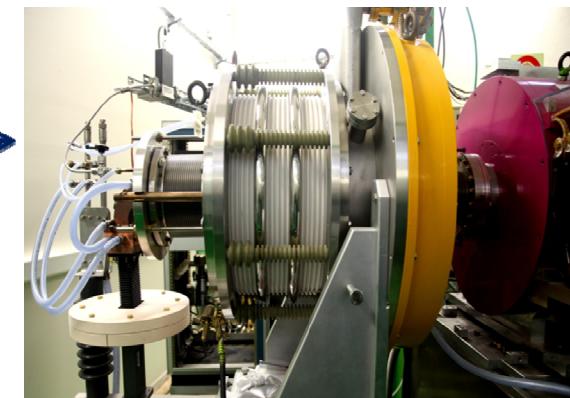
ALISES for a new ECR ion source geometry at Saclay O. Delferrière et al, Rev. Sci. Instrum. 83, 02A307 (2012)



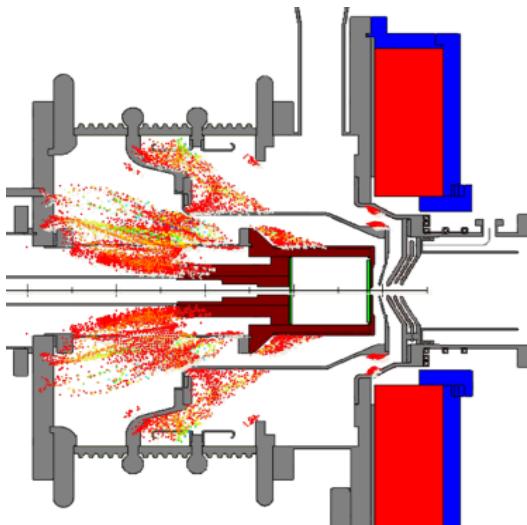
SILHI



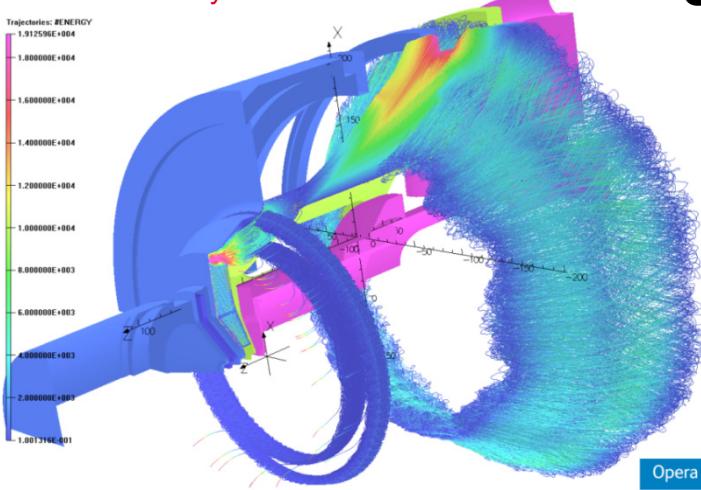
ALISES on BETSI test bench



ECR ION SOURCES DEVELOPMENT AT SACLAY LIMITATION DU TO PENNING DISCHARGES



PhD thesis S. Nyckees

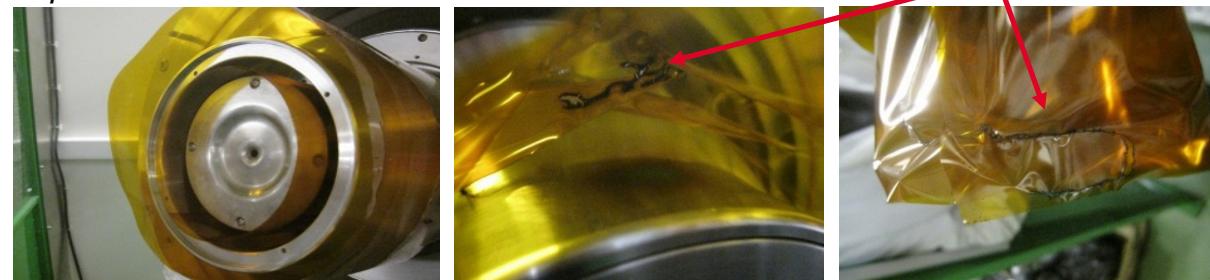


Improvement of extraction system geometry with suppression of possible Penning discharge ignition
Delferrière et al. RSI 85, 02A939 (2014)

Areas where B and E field can be orthogonal:

- ▶ Particles accelerated and trapped, ionization
- ▶ Impacts on biased electrodes, limitation to 23 kV with 18mA , then shutdown of Power Supply

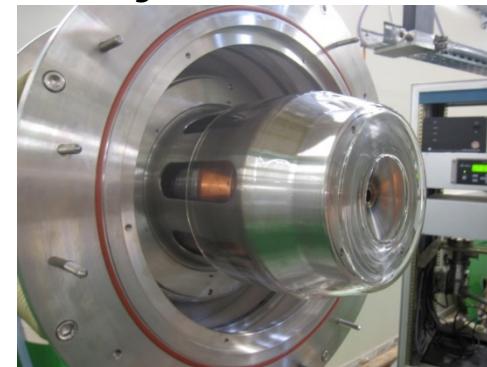
Kapton foils around electrodes



Kapton burned

Simulated with TOSCA and Verified experimentally

Use of glass tubes between electrodes



Cracks on glass



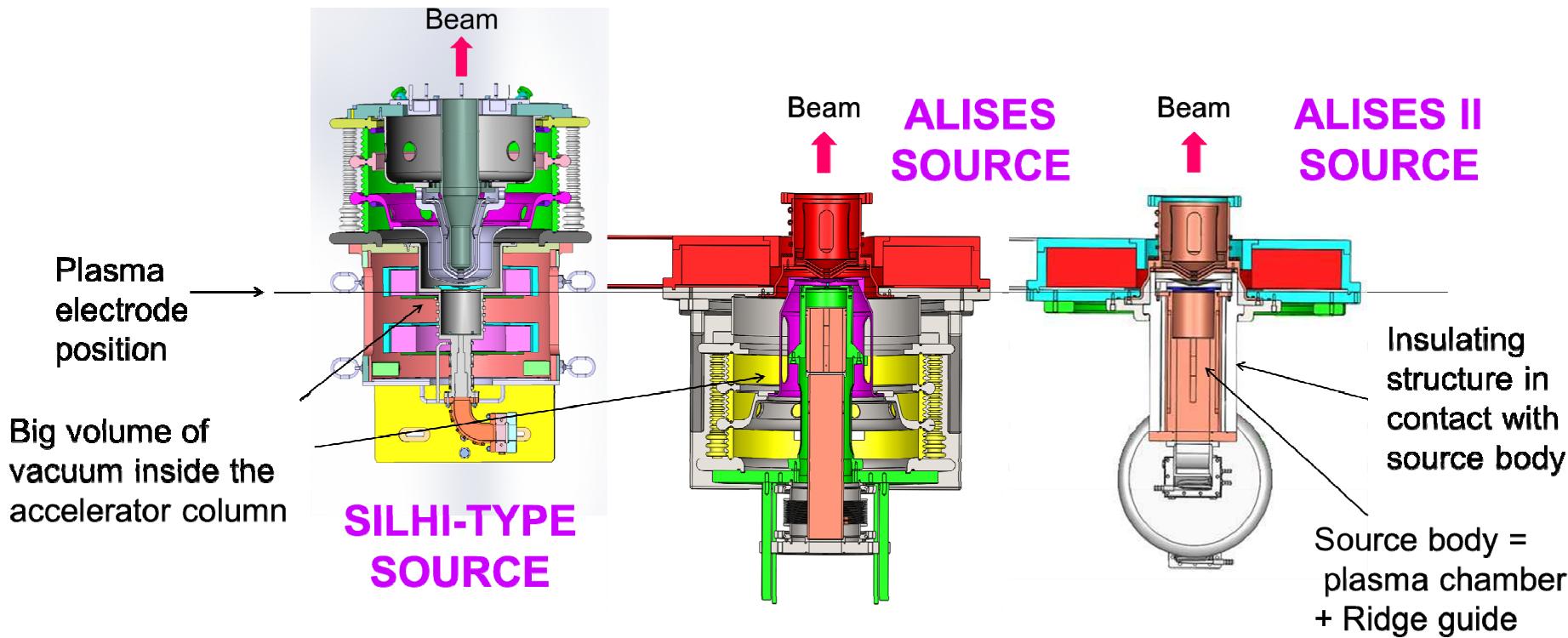
The ALISES II concept:

To face the Penning discharge problem:

- ▶ Eliminate all the vacuum volumes where discharge ignitions occur
- ▶ Very compact structure ALISES II

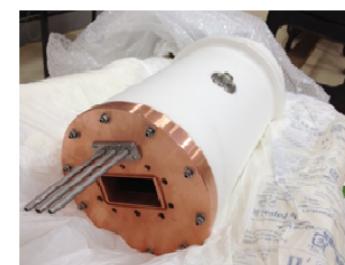
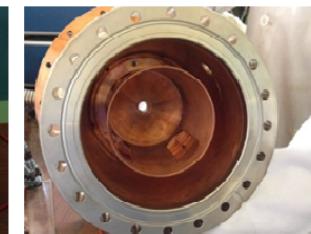
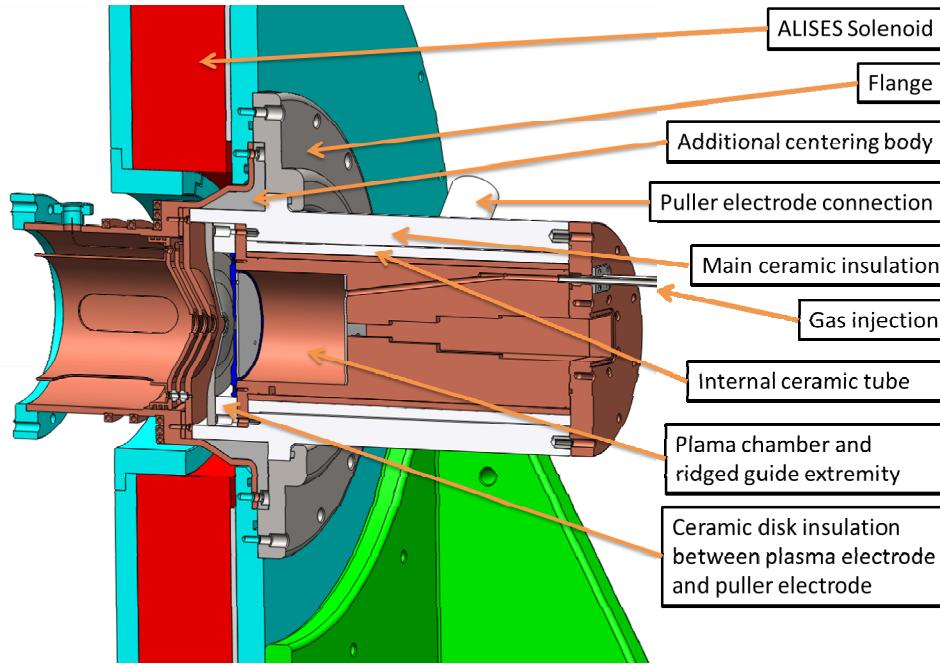
Only one compact part = Insulating structure + plasma chamber +wave guide

The magnet and the extraction chamber are reused from ALISES

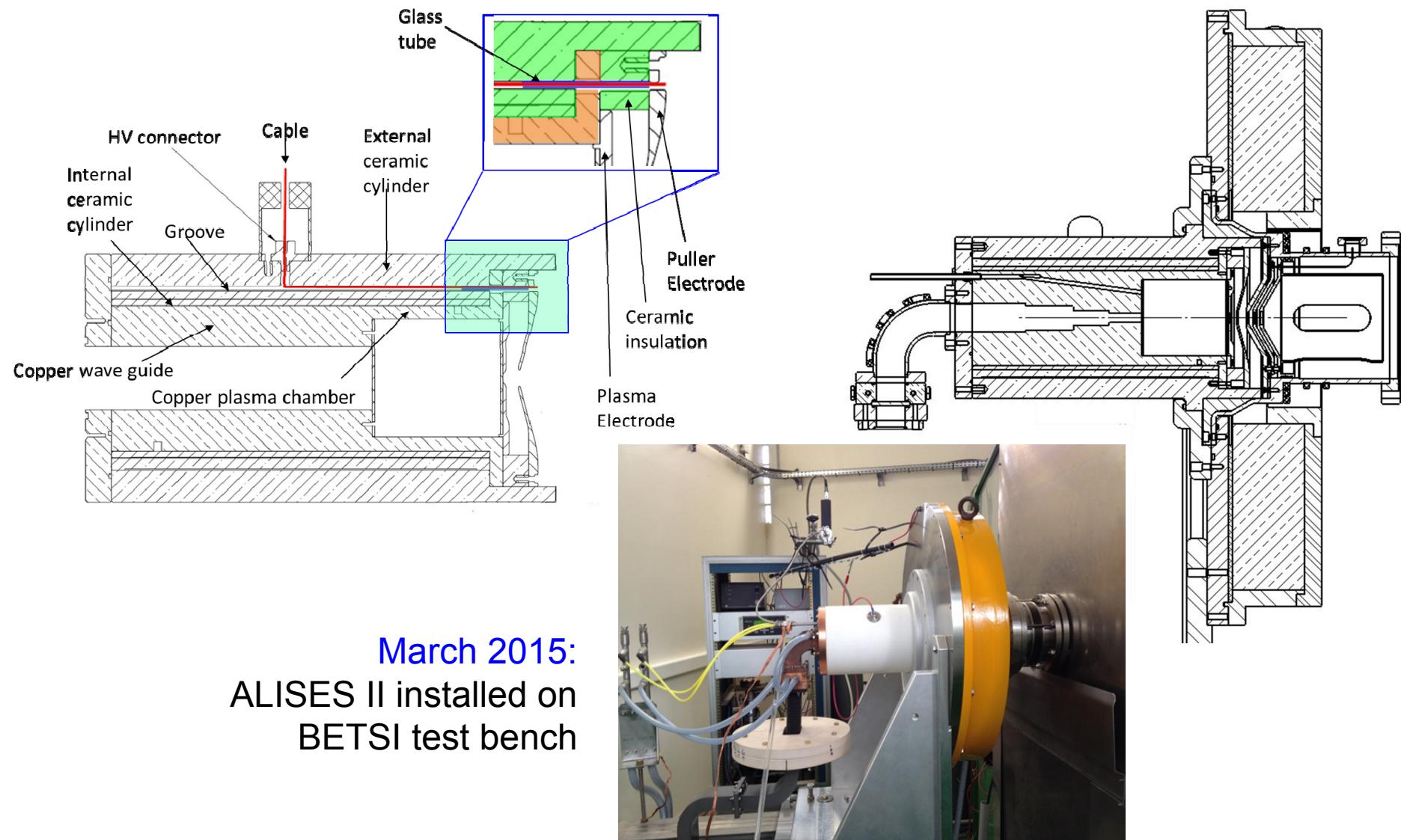


ECR ION SOURCES DEVELOPMENT AT SACLAY ALISES II SOURCE ASSEMBLY

Patent CEA FR 1556871



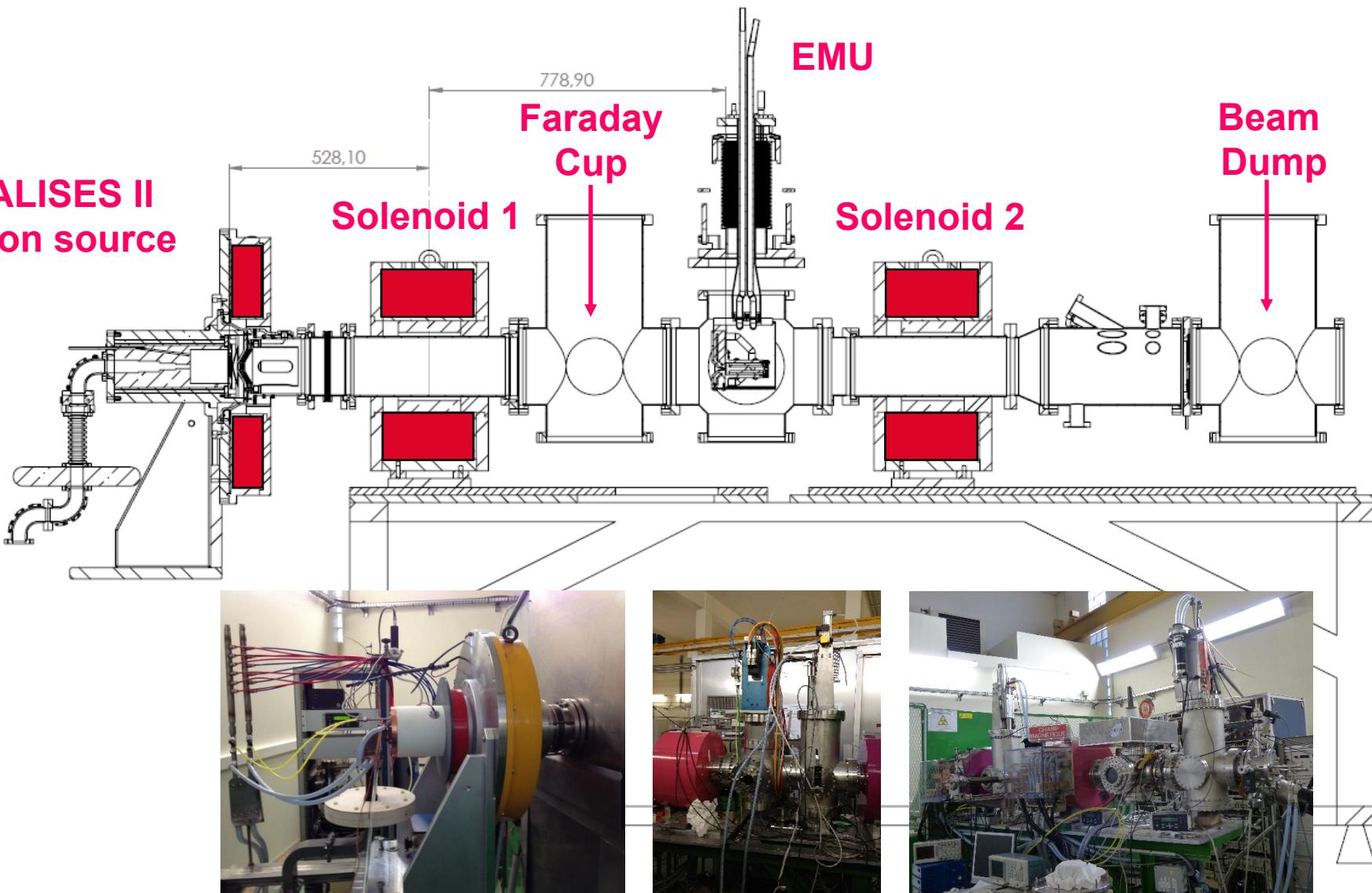
ECR ION SOURCES DEVELOPMENT AT SACLAY PULLER ELECTRODE HV CONNECTION



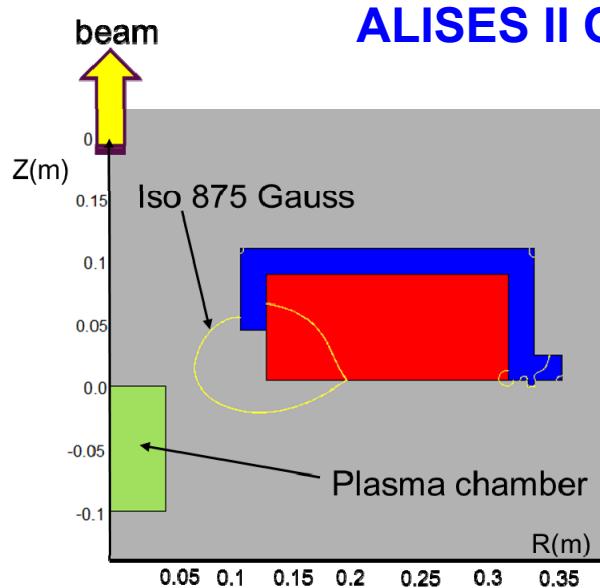
March 2015:
ALISES II installed on
BETSI test bench

ECR ION SOURCES DEVELOPMENT AT SACLAY BETSI EXPERIMENTAL SETUP

ALISES II
Ion source



beam

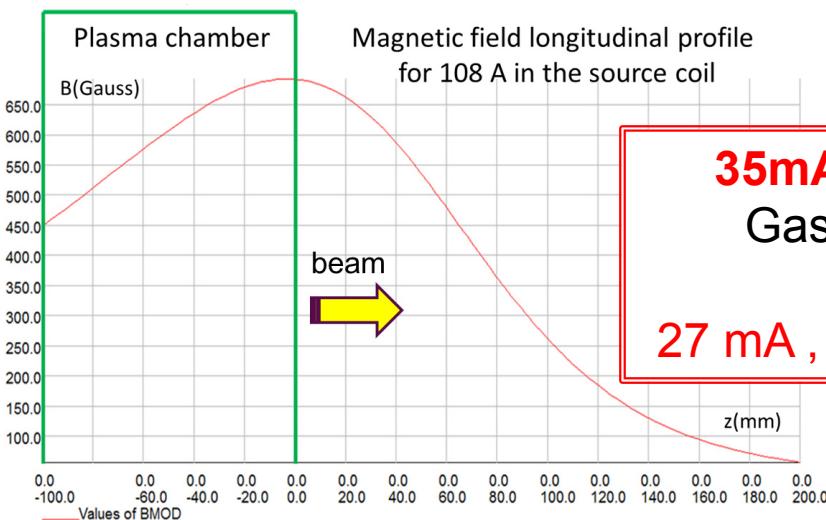


ALISES II OPTIMIZATION:

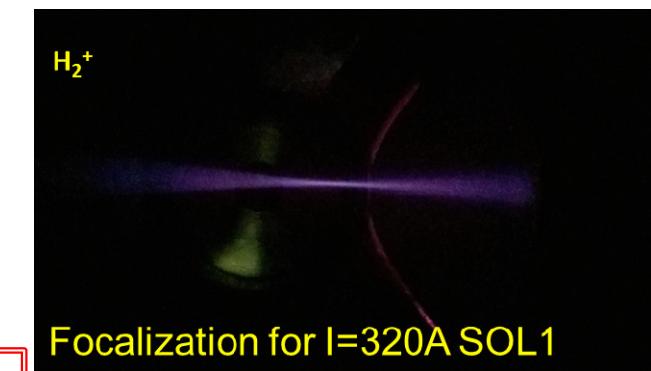
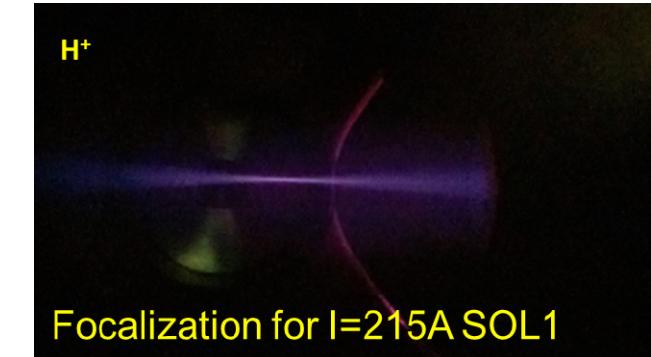
- Φ 6mm plasma electrode
- Source quickly operational
- Reproducibility of the tuning
- Beam very stable

Working point $I=108A$ in ALISES coil:

No resonance @875 Gauss
inside plasma chamber
 $B < 700$ Gauss



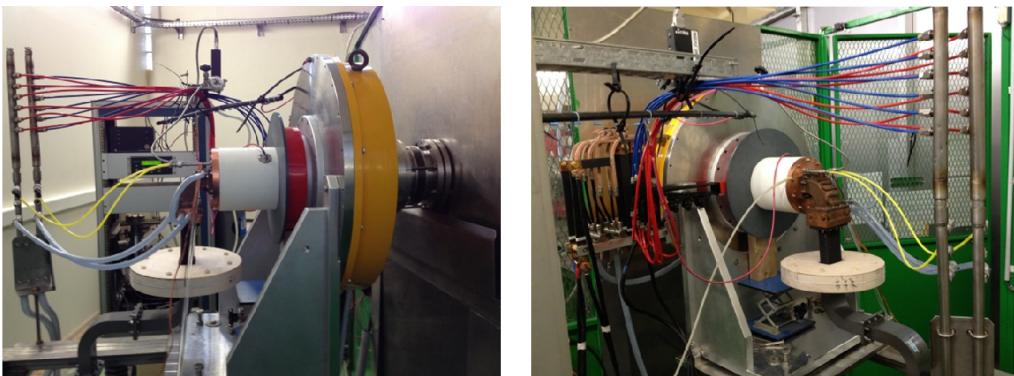
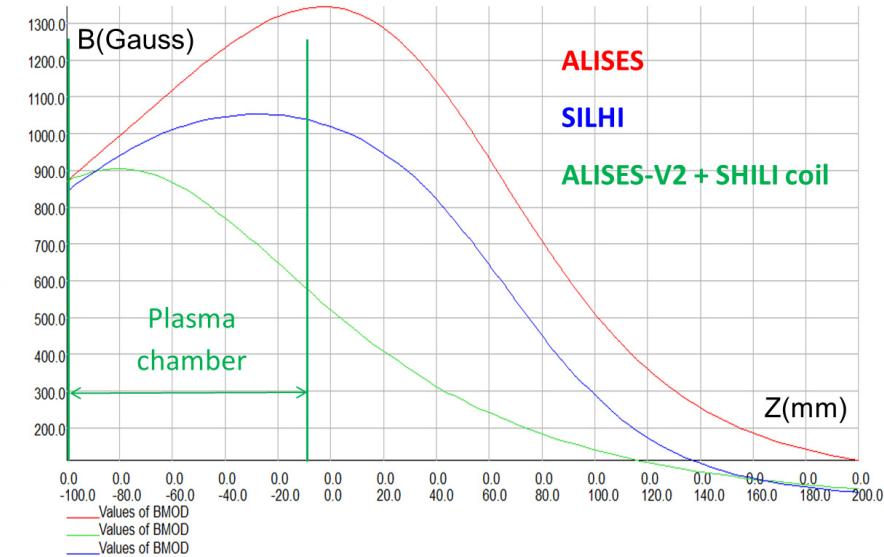
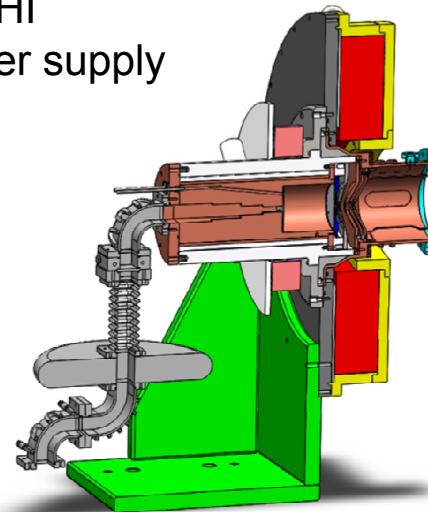
35mA CW @ 50kV
Gas : 1.65 sccm
 $P=980W$
27 mA , end of the LEBT



ECR ION SOURCES DEVELOPMENT AT SACLAY INVESTIGATION ON MAGNETIC FIELD PROFILE

ADDITIONAL SILHI-TYPE COIL ON ALISES II

- Additional electric and magnetic shielding
- Use of a spare coil of SILHI
- Additional 125A/40V power supply
- Additional cooling system



Magnetic configuration optimization

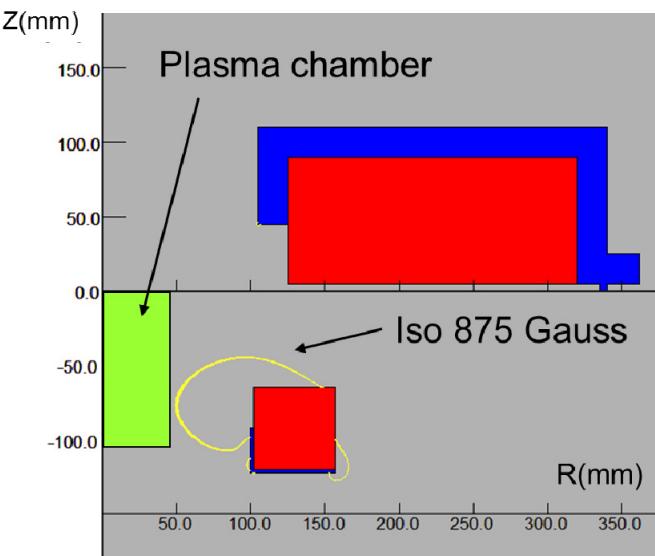
3 possible working modes :

- 1) Initial ALISES source coil: $I=181A$
- 2) Using only additional SILHI-type coil: $I=115A$
- 3) Tuning with both SILHI-type and ALISES source coils

ECR ION SOURCES DEVELOPMENT AT SACLAY

INVESTIGATION ON MAGNETIC FIELD PROFILE

EXTRACTED CURRENT AS A FUNCTION OF MAGNETIC FIELD B PROFILE



Gas : 1.95 sccm
P=700W
Pulsed beam

	ALISES coil (A)	SILHI coil (A)	$I_{\text{extracted}}$ (mA)
	70	70	35,5
	50	85	36,6
	40	88	37
	30	95	37
	0	104	40,7

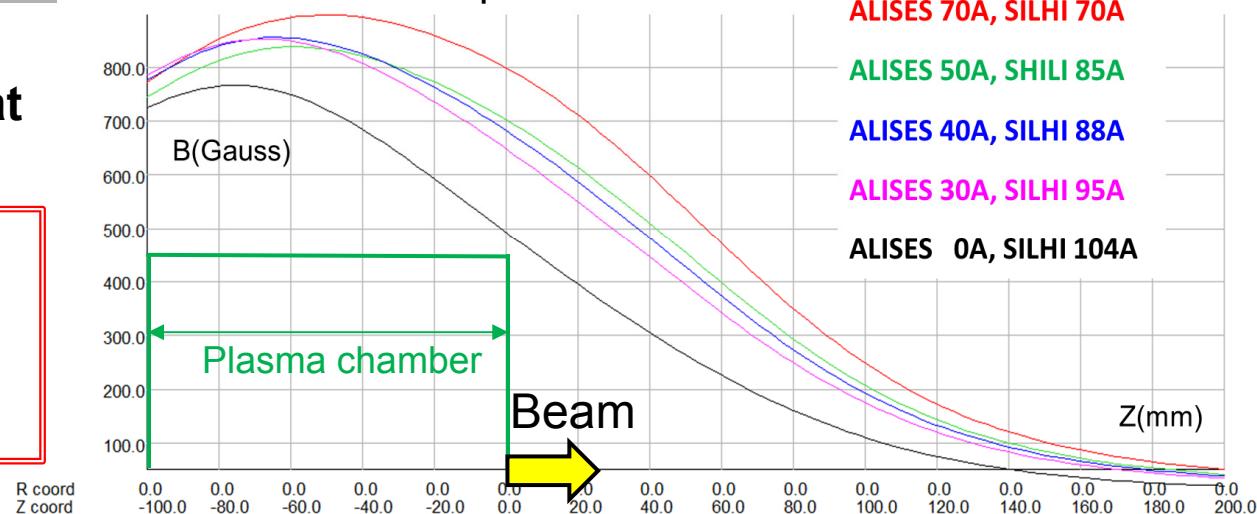
Best result in pulsed mode at
 $I=104\text{A}$ in « SILHI » coil:
No resonance @875 Gauss
inside plasma chamber

Best result in CW mode at
 $I=104\text{A}$ in « SILHI » coil:

48,5 mA CW @ 50kV

Gas : 2,1 sccm
P=700W

26 mA , end of the LEBT

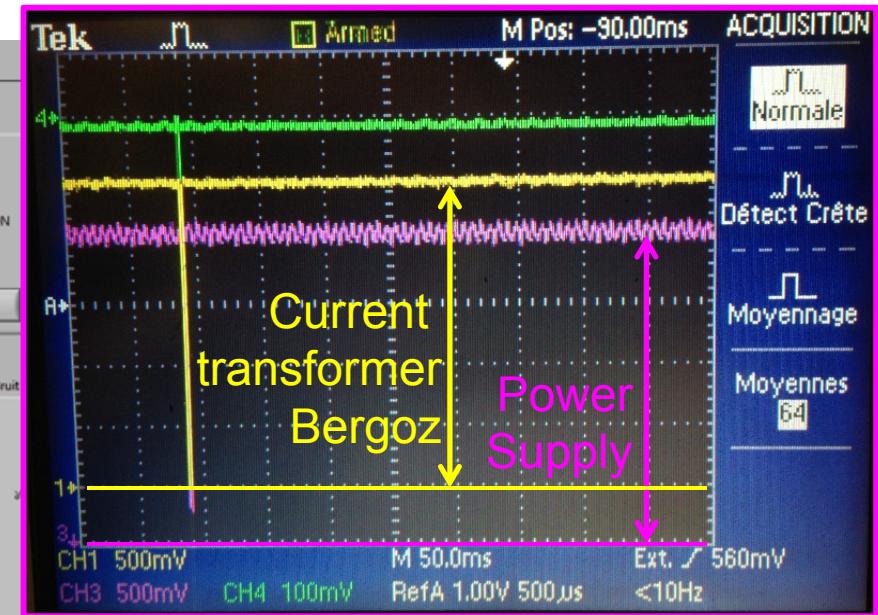
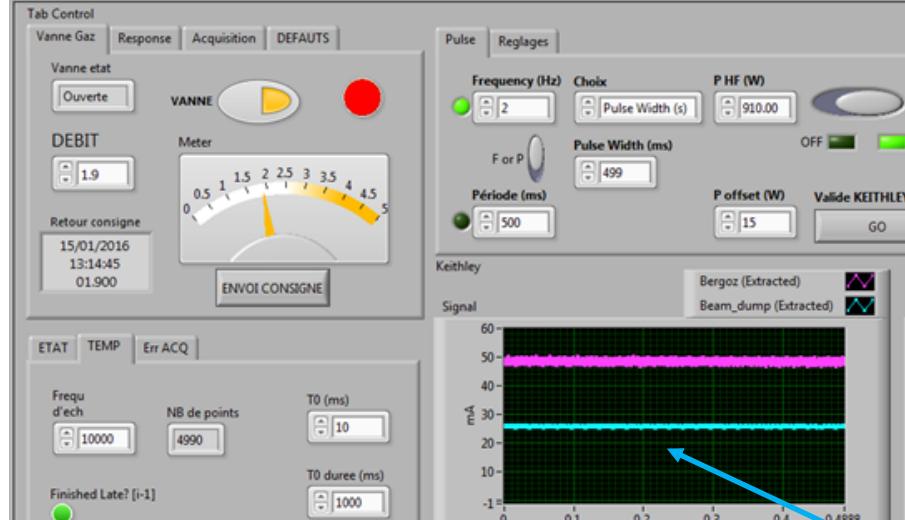


ECR ION SOURCES DEVELOPMENT AT SACLAY

BEST RESULTS ON ALISES II

ALISES V2 extracted beam: 48,5mA@50kV
 CW (499ms/500ms) Gas: 2,1 sccm
 RF Power 700 W

CONTROLE & COMMANDE BETSI

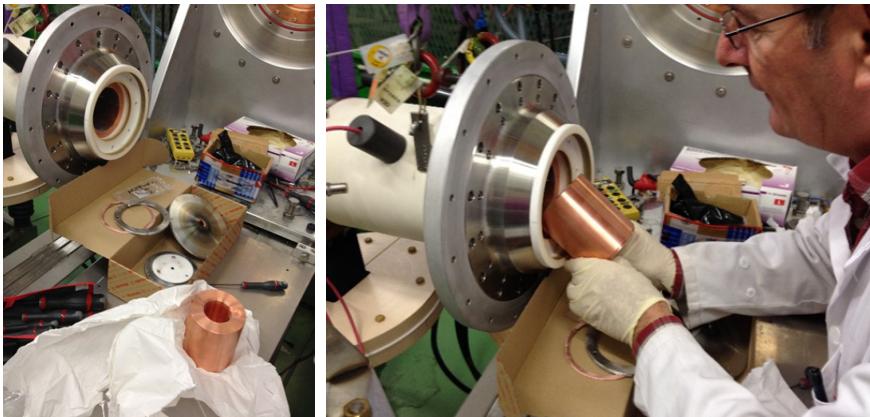
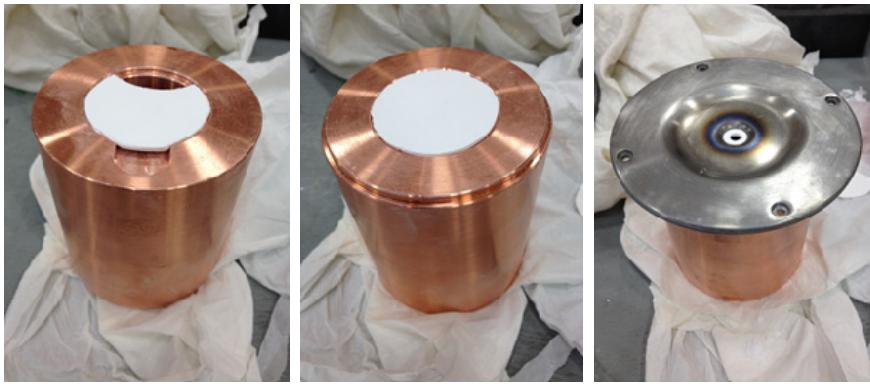


Beam stop
 end of LEBT
 ~ 26mA

ECR ION SOURCES DEVELOPMENT AT SACLAY INVESTIGATION ON PLASMA CHAMBER DIAMETER

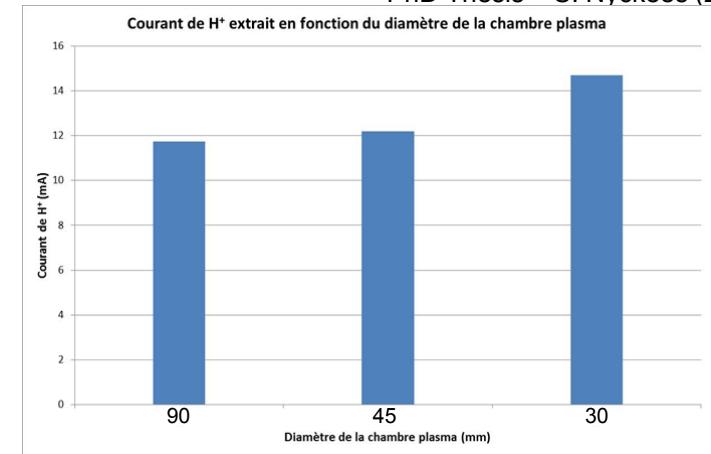
As previously shown on ALISES, reduction of plasma chamber diameter could be beneficial with higher extracted current (more efficient RF heating)

Realization of a $\Phi 45\text{mm}$ copper insert



First experiments on ALISES (2009-2012)

ÉTUDE ET DÉVELOPPEMENT D'UNE NOUVELLE SOURCE ECR PRODUISANT UN FAISCEAU INTENSE D'IONS LÉGERS
PhD Thesis – S. Nyckees (2011)



Extracted current vs Plasma chamber diameter

ALISES V2 extracted beam @40kV

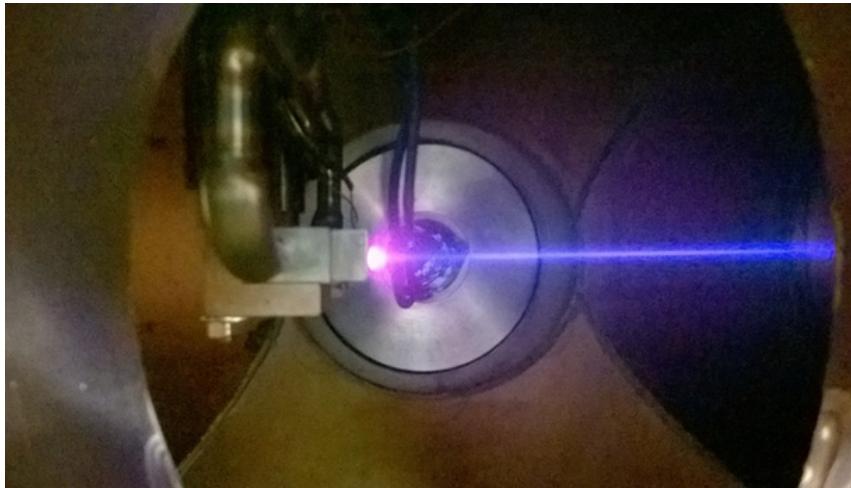
	$\Phi 45\text{mm}$	$\Phi 90\text{mm}$
B(A)	108	105
P(W)	750	700
Gas(sccm)	1,75	1,47
I_{ext} (mA)	40,5	36,7

ECR ION SOURCES DEVELOPMENT AT SACLAY LAST RESULTS BEFORE SHUTDOWN OF BETSI

Performances and stability of the source:

- Several experiments have been done with ALISES II on BETSI

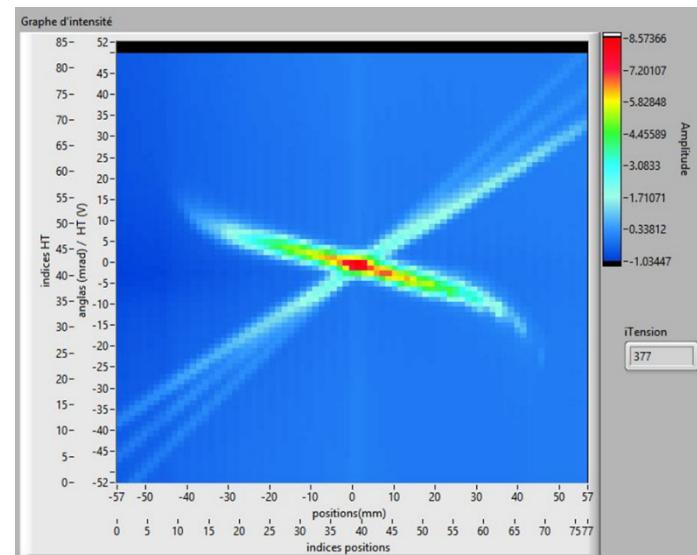
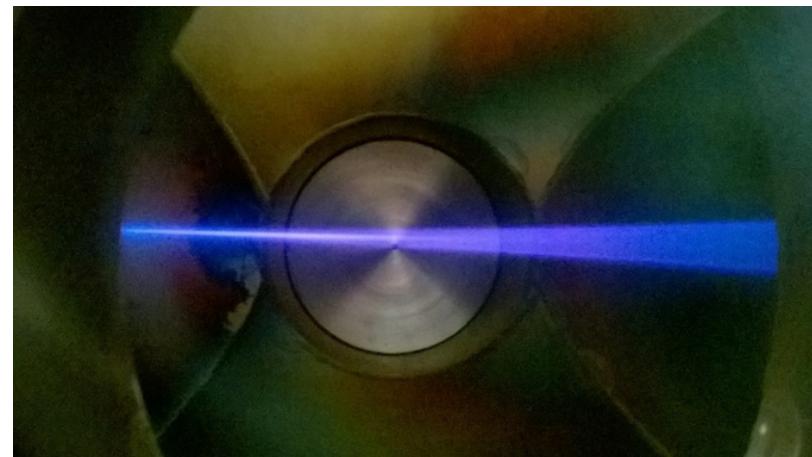
- 1) Irradiation of scintillators for 4D emittance meter
- 2) Space charge compensation measurement with 4 grid analyzer
- 3) Bombardment of beam stop prototype for S3 spectrometer experiment (SPIRAL2 project)
- 4) Emittance measurements with a new Allison scanner for FAIR proton linac injector (debugging phase)



Hydrogen beam 35mA@40kV extracted from ALISES, 17mA H⁺ at the end of BETSI LEBT on beam stop prototype for S3

Olivier DELFERRIERE

22nd International Workshop on ECR ion Sources – Busan, Korea 28 August-1 September 2016



First emittance measurement with ALISES II
Very preliminary results

Performances and stability demonstrated: almost 50mA@50 kV with plasma Φ 6mm

Since March 2016, BETSI has been shutdown for upgrade to 100 kV

► Q4 2016: BETSI ready @100kV

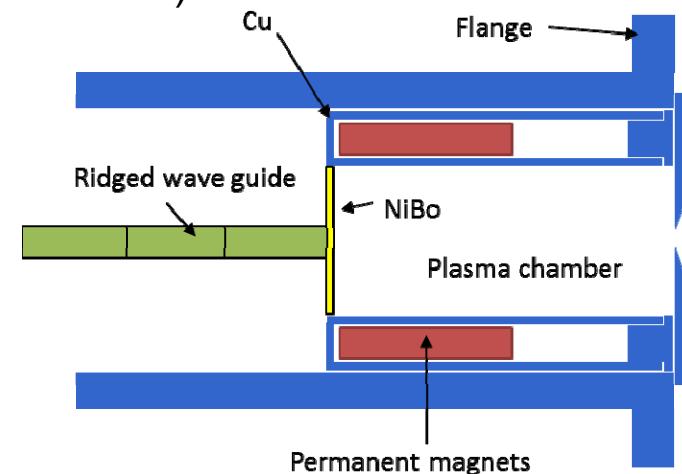
ALISES II on 100kV BETSI test bench :

- Up to now BETSI was limited to 50 kV: test up to 100 kV with plasma Φ 9mm (ALISES II already successfully tested up to 70 kV without beam)
- Emittance measurements with Allison scanner
- Proportions to be analyzed with a Wien filter
- Permanent magnet version to be tested (magnets already ordered)
- Magnetic field profile investigation to continue

ALISES III under construction:

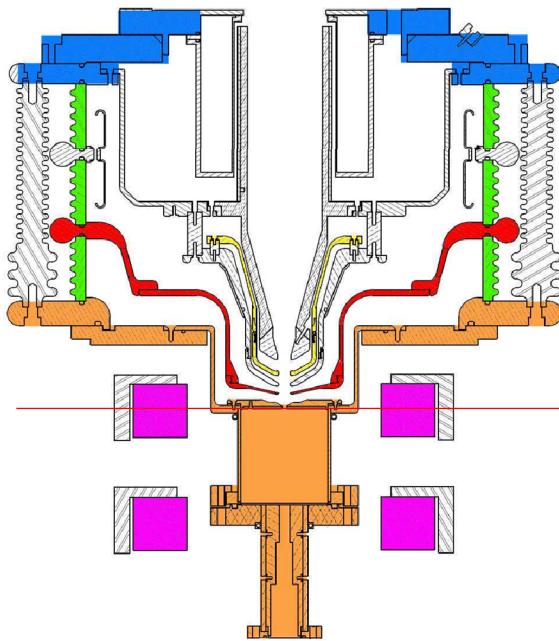
To be assembled and tested Q4 2016

- New HV connection for puller electrode
- Magnetic field obtained with a smaller coil as SILHI coils
- Φ 45mm plasma chamber
- No support, source directly connected to the LEBT

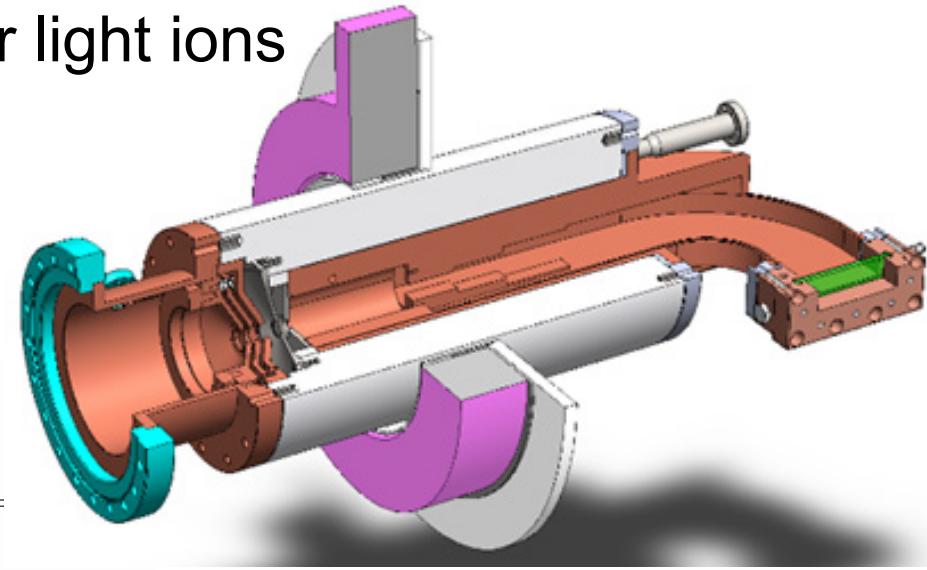
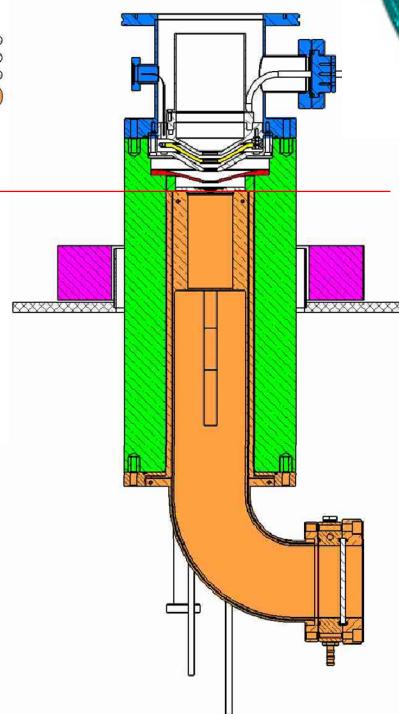


High intensity ECR ion sources for light ions

Conventional



ALISES III



STRONG POINTS:

- LEBT length gain
- Geometry simplified
- Easier maintenance
- Compactness
- Only 40-50 kg
- No HV platform
- Lower price

Thank you for your attention



HIGH INTENSITY ECR IONS SOURCES

RESULT OF 20 YEARS OF EXPERIENCE

